IFW



PATENT 8007-1087

## IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Kiyotaka YASUDA et al.

Conf. 6850

Application No. 10/522,791

Group 1745

Filed September 22, 2005

Examiner unknown

NEGATIVE ELECTRODE FOR NONAQUEOUS ELECTROLYTE SECONDARY BATTERY, METHOD FOR MANUFACTURING SAME AND NONAQUEOUS ELECTROLYTE SECONDARY BATTERY

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of these items is that these references were cited by the Japanese Patent Office in the corresponding Japanese Application Serial No. 2003-290726. A copy of the Japanese Official Action in which they were cited is attached hereto. An English translation is also attached hereto.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a

Docket No. 8007-1087 Appln. No. 10/522,791

counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON

Robert J. Patch, Reg. No. 17,355

745 South 23<sup>rd</sup> Street
Arlington, VA 22202
Telephone (703) 521-2297
Telefax (703) 685-0573
(703) 979-4709

RJP/fb

July 3, 2007

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)		Attorney Docket No.: 8007-1087  Applicant: Kiyotaka YASUDA et al.  Filing Date: September 22, 2005		Application No.: 10/522,791 0 P E		
				Group Art Units 1745		
	U.S. PATE	NT DOCUMENTS			B TRI	DEMA
Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)	
	FOREIGN PA	TENT DOCUMENTS				
Document Number	Date	Country	Cla	ass Subclass		slation No
2001-68096*	3/16/01	JAPAN			1.00	
11-250896*	9/17/99					
4-294059*	10/19/92	JAPAN			_	
OTHER DOCUMEN	NTS (Including /	 Author, Title, Date, Pertir	nent Page	s, Etc.)		
<b>O</b> 111 <b>L</b> 11 D 3 3 3 1 1 1						
NER:		DATE CONSIDERED				
	IN AN APPLICATION (Use several sheets if necess)  Document Number  Document Number  2001-68096* 11-250896* 4-294059*	U.S. PATEN	RMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)  U.S. PATENT DOCUMENTS  Document Number  Date  FOREIGN PATENT DOCUMENTS  Document Number  Date  Country  2001-68096* 11-250896* 9/17/99 10/19/92  OTHER DOCUMENTS (Including Author, Titte, Date, Perting Author, Titte, Date, Per	RMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)  U.S. PATENT DOCUMENTS  Document Number  Date  Name  Class  FOREIGN PATENT DOCUMENTS  Document Number  Date  FOREIGN PATENT DOCUMENTS  Document Number  Date  Country  Class  11-250896*  9/17/99  4-294059*  OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Page	RMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)    Comparison   Comparison	RMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)    Variety of the component

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* English language abstract provided for the Examiner's convenience